



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al.                      Art Unit : 2814  
Serial No. : 09/903,339                      Examiner : Theresa T. Doan  
Filed : July 10, 2001  
Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM  
SEMICONDUCTOR DEVICE

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF FEBRUARY 12, 2004

Please amend the above-identified application as follows.

The listing of claims begins on page 2.

The remarks begin on page 10.

07/14/2004 WABRHAM1 00000116 09903339

01 FC:1202	216.00 OP
02 FC:1201	258.00 OP